

10-24-2001

ASSIGNMENT RECO.
-PATEI



101885045

To: Honorable Commissioner of Patents and Trademarks:

10/09/01
09/975125
U.S. PTO

Please record the attached original document or copy thereof.

1. Name of conveying parties:

- | | |
|-------------------|--------------------|
| a) Jin-shown Shie | d) Chih-tang Peng |
| b) Ji-cheng Lin | e) Shih-han Yu |
| c) Chun-te Lin | f) Kuo-ning Chiang |

2. Name and address of receiving party:

- a) Name: Integrated Crystal Technology Corporation
Address: 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.

3. Nature of conveyance

- | | |
|--|--|
| <input checked="" type="checkbox"/> Assignment | <input type="checkbox"/> Merger |
| <input type="checkbox"/> Security Agreement | <input type="checkbox"/> Change of Name |
| <input type="checkbox"/> Other | <input type="checkbox"/> License Agreement |

Execution Dates: September 28, 2001, September 21, 2001, September 21, 2001, September 21, 2001, September 27, 2001, and September 1, 2001, respectively.

4. Application Number or Patent Number: Not yet assigned

The title of the new application is: SILICON PRESSURE MICRO-SENSING DEVICE AND THE FABRICATION PROCESS

5. Please send all correspondence concerning this document to:

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10/16/2001 EMAILE1 00000056 09975125

02 FC:581

40.00 DP


6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41): \$40.00

- ☒ Enclosed
☒ Authorized to be charged to Deposit Account No. 50-0805
(Order No. JLINP066)

8. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Date: October 9, 2001


Albert S. Penilla, Esq.
Registration No. 39,487

Attorney Docket No. JLINP066

(Revised 01/96)

PATENT
REEL: 012269 FRAME: 0535

ASSIGNMENT OF PATENT APPLICATION

Q0899

For good and valuable consideration, receipt of which hereby acknowledged,

I/We,

- (a) Jin-shown SHIE
- (b) Ji-cheng LIN
- (c) Chun-te LIN
- (d) Chih-tang PENG
- (e) Shih-han YU
- (f) Kuo-ning CHIANG

residing at

- (a) 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.
- (b) 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.
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- (d) 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.
- (e) 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.
- (f) 3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.

assign and transfer to: **Integrated Crystal Technology Corporation**

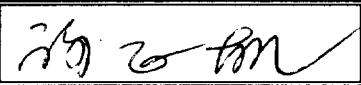
a corporation organized under the law of Taiwan and having a place of business at :

3F, No. 212, Ta Hsueh Road, Hsin Chu, Taiwan, R.O.C.

its successors and assigns, my entire right, title and interest, including the right of priority, in, to and under an application for Letters Patent of the United States entitled:

SILICON PRESSURE MICRO-SENSING DEVICE AND THE FABRICATION PROCESS

including divisions, reissues, continuations and extensions thereof, and all rights of priority without further authorization from me; I agree to execute all papers useful in connection with said United States application, and generally to do everything possible to aid said assignee, its successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in United States; and I request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Joint Inventor (a)	Jin-shown SHIE		
Inventor's Signature		Date	Sept 28, 2007
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.

Joint Inventor (b)	Ji-cheng LIN		
Inventor's Signature	<i>Ji-Cheng Lin</i>	Date	<i>Sep. 21, 2001</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.

Joint Inventor (c)	Chun-te LIN		
Inventor's Signature	<i>Chun-Te Lin</i>	Date	<i>9, 21, 2001</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.

Joint Inventor (d)	Chih-tang PENG		
Inventor's Signature	<i>Chih-Tang Peng</i>	Date	<i>9, 21, 2001</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.

Joint Inventor (e)	Shih-han YU		
Inventor's Signature	<i>Shih-han Yu</i>	Date	<i>9.21.2001</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.

Joint Inventor (f)	Kuo-ning CHIANG		
Inventor's Signature	<i>[Signature]</i>	Date	<i>01/09/26</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.